

ATTORNEY DOCKET NO: 73477

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : ZAKEL et al.
Serial No : 10/582,421
Confirm. No : 4850
Filed : December 22, 2004
For : METHOD AND DEVICE...
Art Unit : 3744
Examiner : N/A
Dated : November 29, 2010

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Please consider the following references cited in a Final Decision of Rejection of September 21, 2010 in the corresponding Japanese patent application. Enclosed is an English translation of the Final Decision of Rejection of September 21, 2010.

- JP 11-507121. The reference discloses a method of drying substrates. A copy of the reference is attached. No English translation is available to Applicant at this time, however, Applicant has attached an English-language abstract. Applicant also wishes to disclose the corresponding U.S. patent, US 6,539,956 A1.

- JP 10-321583. The reference discloses a method for drying a substrate. A copy of the reference is attached. No English translation is available to Applicant at this time, however Applicant has attached an English-language abstract.

- JP 09-186127. The reference discloses a semiconductor wafer cleaning and drying

method. A copy of the reference is attached. Applicant has also attached a machine English translation of the reference.

Each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement.

Consideration of the above references is requested.

Respectfully submitted
for Applicant,



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- and -



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Attached: PTO/SB/08a Form
English translation of the Final Decision of Rejection of September 21, 2010
Copy of (3) References
Copy of (2) English-language Abstracts
Copy of (1) English Translation

JJM:BMD

73477-10

DATED: November 29, 2010
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SHOULD ANY OTHER FEE BE REQUIRED, THE PATENT AND TRADEMARK
OFFICE IS HEREBY REQUESTED TO CHARGE SUCH FEE TO OUR DEPOSIT
ACCOUNT 13-0410.